

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wayne G. Renken  
Assignee: SensArray Corporation  
Title: Process Condition Sensing Wafer and Data Analysis System  
Application No.: 10/685,550 Filing Date: October 14, 2003  
Examiner: Charles D. Garber Group Art Unit: 2856  
Docket No.: SENS.005US1 Conf. No.: 4924

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I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on February 16, 2005

Helen A. Jackson  
Helen A. Jackson

San Francisco, California  
February 16, 2005

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE OF ABANDONMENT**

Sir:

Applicant hereby responds to the Notice of Abandonment dated February 7, 2005, in the above-referenced application wherein the Examiner states that a response was never received to the Office Action dated June 29, 2004.

Applicant submits that this notice was sent in error. A timely response was mailed on September 23, 2004. Attached are copies of

1. Return Receipt Postcard date stamped September 27, 2004;
2. Amendment Transmittal; and
3. Amendment in response to June 29, 2004, Office Action (12 pages).

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In view of the above, we respectfully request that the holding of abandonment be withdrawn. If a telephone call would expedite this request, please call Attorney for Applicant shown below at (415) 318-1160.

Respectfully submitted,



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